



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: **Hisashi NAKAMURA et al.**

Group Art Unit: **2675**

Serial Number: **10/073,959**

Examiner: **Ming Hun Liu**

Filed: **February 14, 2002**

PTO Confirmation No.: **8711**

For: **LIQUID CRYSTAL PROJECTOR COOLING SYSTEM DEPENDENT ON
AIR PRESSURE AND TEMPERATURE VARIABLES**

Attorney Docket No.: **042288**

RECEIVED

Customer No.: 38834

JUL 21 2004

RESPONSE

Technology Center 2600

Mail Stop: AF

Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

July 19, 2004

Sir:

In response to the Office Action dated April 19, 2004, Applicants request
favorable reconsideration the above-referenced application as follows:

Arguments/Remarks begin on page 2 of this paper.

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